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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Group Art Unit: 2813
Examiner: Jack S. J. Chen

In Re PATENT APPLICATION of:

Applicant(s): Toshikazu MIZUKOSHI)

Serial No.: 10/635,506)

Filed: August 7, 2003)

For: METHOD OF FABRICATING A)
SEMICONDUCTOR DEVICE TRENCH)
HAVING AN OXIDE FILM ON A)
CORNERED PORTION THEREOF)

AMENDMENT

Docket No.: OKI 361)

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In response to the Examiner's Action mailed on October 18, 2004, please
amend the above-identified application as follows:

FEE ENCLOSED: \$
Please charge any further
fee to our Deposit Account
No. 18-0002